

What is claimed is:

1. An apparatus for managing a liquid crystal substrate comprising:

5 a data management section having a database for recording a defect information acquired from a liquid crystal testing device, and an image information and a repair information including a defect repaired information which are acquired from a liquid crystal repair device, said data management section performing at least one of a reidentification of a defect and
10 a redetermination of at least one of a panel and a substrate based on the defect information, the image information and the repair information recorded in said database.

2. The liquid crystal substrate managing apparatus
15 according to claim 1, wherein said data management section stores a recipe information for defining specifications of the substrate and panel in said database, said recipe information being edited freely.

20 3. The liquid crystal substrate managing apparatus according to claim 2, wherein said data management section edits the recipe information by exchange of information with a terminal connecting to the data management section.

25 4. A method for managing a liquid crystal substrate

comprising:

recording a defect information acquired from a liquid
crystal testing device, and an image information and a repair
information including a defect repaired information which are
5 acquired from a liquid crystal repair device in a database;
and

performing at least one of a reidentification of a defect
and a redetermination of at least one of a panel and a substrate
based on the defect information, the image information and the
10 repair information recorded in the database.

5. The liquid crystal substrate managing method
according to claim 4, further comprising:

recording a recipe information acquired from the liquid
15 crystal testing device in the database, the recipe information
defining specifications of the substrate and panel and being
edited freely.